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## 08/223,739 | 160246: METHOD OF DEPOSITING A GALLIUM NITRIDE-BASED III-V GROUP COMPOUND SEMICONDUCTOR CRYSTAL LAYER

Public view

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Application Data

Documents & Transactions

Continuity

Patent Term Adjustment

Foreign Priority


Fee Payment History

Address & Attorney/Agent Information

Supplemental Content

Assignments

Display References


Application #	Attorney Docket #	Patent #	Status	Filing or 371 (c) date
08/223,739	160246	5,433,169  Issued - 07/18/1995	Patent Expired Due to NonPayment of Maintenance Fees Under 37 CFR 1.362 - 08/13/2007	04/06/1994

### IFW and transaction history

Documents

Transactions

None selected

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